



PATENT  
Attorney Docket No: AUB-06300

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yonhua Tzeng

Serial No.: 10/772,740

Filed: February 5, 2004

For: **METHOD OF PLASMA  
ENHANCED CHEMICAL VAPOR  
DEPOSITION OF DIAMOND  
USING METHANOL-BASED  
SOLUTIONS**

) Group Art Unit: 1762

) Examiner: Stouffer, Kelly M.

) **AMENDMENT AND REQUEST FOR  
CONTINUED EXAMINATION (RCE)**

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Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

**AMENDMENTS**

Sir:

Please amend the subject application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

CERTIFICATE OF MAILING (37 CFR § 1.8(a))  
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Date: 5/11/07 By: Miriam Fleener